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Substitute for form 1449A/B/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(Use as many sheets as necessary)</i>				<i>Complete if Known</i>	
				Application Number	Unassigned
				Filing Date	February 11, 2002
				First Named Inventor	Isaac K. CHERIAN
				Group Art Unit	Unassigned
				Examiner Name	Unassigned
Sheet	1	of	1	Attorney Docket Number	1000045

U.S. PATENT DOCUMENTS						
Examiner Initials	Doc. No.	U.S. Patent Document		Name of Patentee or Applicant	Date of Publication	Filing Date If Appropriate
		Application or Patent Number	Kind Code			
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		Office	Application or Patent Number	Kind Code				
	AS	EP	1 036 836	A1	Kabushiki Kaisha Toshiba	September 20, 2000		
	AT	EP	1 104 778	A2	JSR Corporation	June 6, 2001		
	AU	EP	1 118 647	A1	Praxair S.T. Technology, Inc.	July 25, 2001		
	AV	WO	99/64527	A1	Rodel Holdings, Inc.	December 16, 1999		
	AW	WO	01/02134	A1	Rodel Holdings, Inc.	January 11, 2001		
	AX	WO	01/14496	A1	Rodel Holdings, Inc.	March 1, 2001		
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	AZ	JP	64-87146	A	Lion Corp.	March 31, 1989		X ⁺
	BA	JP	2000-164631	A	Matsushita Denki Sangyo KK	June 16, 2000		X ⁺

Examiner Signature	<i>[Signature]</i>	Date Considered	2/23/04
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* A concise statement of relevance is being submitted in lieu of a translation. 37 CFR 1.98(a)(3).

+ An English-language equivalent/patent, or an English-language abstract, or an English-language version of the search report or action by a foreign patent office in a counterpart foreign application indicating the degree of relevance found by the foreign office is being submitted in lieu of a concise explanation of relevance under 37 CFR 1.98(a)(3).

FOREIGN PATENT DOCUMENTS						
Examiner Initials	Cite No.	Foreign Patent Document	Publication Date	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines Where Relevant Passages Or Figures Appear	T
		Country Code-Number-Kind Code (if known)				
<u> </u>	1.	WO 01 12740 A1	Feb. 22, 2001	Wang et al.		

OTHER DOCUMENTS (NON-PATENT LITERATURE DOCUMENTS)			
Examiner Initials	Cite No.	Author's NAME, title of the article, book, magazine, journal, serial, symposium, catalog, etc., date, page(s), volume-issue number(s), publisher, city and/or country of publication	T
	2.	MCNAMEE, C.E. et al: Adsorption of quarternised polyvinylpyridine and subsequent counterion binding of perfluorinated anionic surfactants on silica as a function of concentration and pH: a zeta potential study" COLLOIDS AND SURFACES, A: PHYSICOCHEMICAL AND ENGINEERING ASPECTS (2001), 193, 175-185	no month
	3.	SCHWARZ, S. et al: "Polyelectrolyte adsorption on charged surfaces: study by electrokinetic measurements" COLLOIDS AND SURFACES, A: PHYSICOCHEMICAL AND ENGINEERING ASPECTS (1998), 140(1-3), 377-384	no month
	4.	SCHWARZ, S. et al: "Adsorption and stability of colloidal silica" COLLOIDS AND SURFACES, A: PHYSICOCHEMICAL AND ENGINEERING ASPECTS (2000), 163(1), 17-27	(no months)

Examiner's Signature: W. H. Hall Date Considered: 2/23/04